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# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

File application of: Cho et al.

Atty Docket No.:  
NOVLP089/NVLS-2886/2887

Application No.: 10/800,377

Examiner: Picardat, Kevin M.

Filed: March 11, 2004

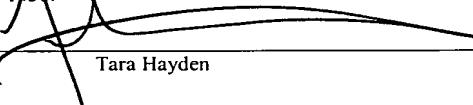
Group: 2822

Title: METHOD AND APPARATUS FOR UV  
EXPOSURE OF LOW DIELECTRIC  
CONSTANT MATERIALS FOR POROGEN  
REMOVAL AND IMPROVED MECHANICAL  
PROPERTIES

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on January 11, 2007 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: \_\_\_\_\_

  
Tara Hayden

## PETITION TO REVIVE UNINTENTIONALLY ABANDONED APPLICATION OR LAPSED PATENT (37 CFR 1.137(b))

Mail Stop Petition  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

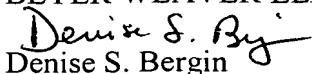
Sir:

Applicant hereby petitions that the abandoned application or lapsed patent be revived. The entire delay in filing the required reply from the due date for the reply until the filing of a grantable petition pursuant to 37 CFR 1.137(b) was unintentional.

The required reply  is attached.  has been filed.  
 is a continuing application which is attached.  
 is a Request for Continued Examination which is attached.

- A terminal disclaimer if required by 37 CFR 1.137(c) is attached.
- Check No. \_\_\_\_\_ in the amount of \$1,500.00 for a Large Entity is enclosed for the petition fee (1.17(m)).
- The Commissioner is authorized to charge \$1,500.00 and any fees beyond the amount, which may be required, or to credit any overpayment, to Deposit Account No. 500388 (Order No. NOVLP089).

01/18/2007 AWONDAF1 00000073 500388 10800377  
01 FC:1453 1500.00 DA

Respectfully submitted,  
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